

Notice of References Cited

Application/Control No.

10/825,673

Applicant(s)/Patent Under
Reexamination
ENDO ET AL.

Examiner

CHIA-WEI A. CHEN

Art Unit

2622

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,887,107	12-1989	Nakamura et al.	396/75
*	B	US-6,978,089	12-2005	Nomura et al.	396/75
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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